

Recitation Class for Final Exam

Chapter 10-12

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2021.08.03

Outline

Chapter 10 - Fundamentals of the Metal–Oxide–Semiconductor Field-Effect Transistor

Chapter 11 - Metal–Oxide–Semiconductor Field-Effect Transistor: Additional Concepts

Chapter 12 - Bipolar Junction Transistor

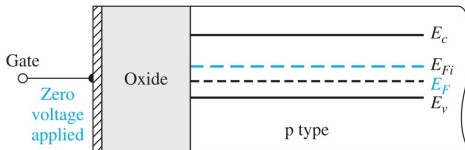
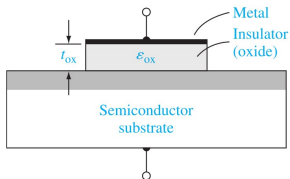
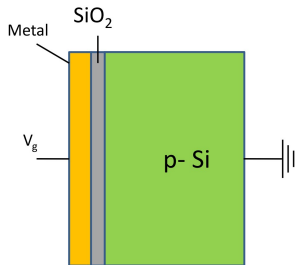
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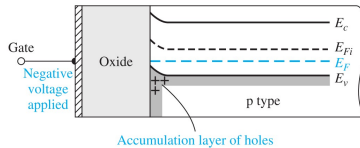
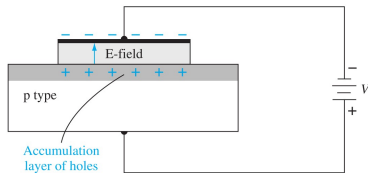
Chapter 11 - Metal–Oxide–Semiconductor Field-Effect Transistor:
Additional Concepts

Chapter 12 - Bipolar Junction Transistor

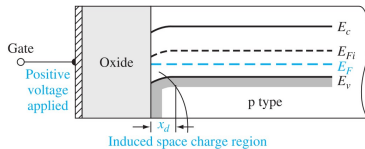
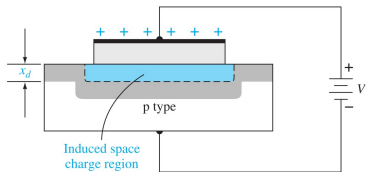
Metal–Oxide–Semiconductor



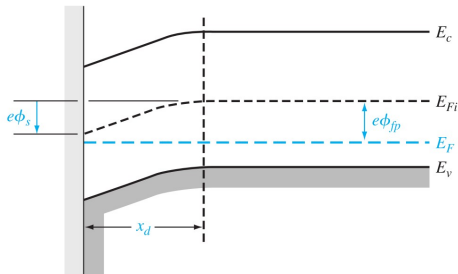
Negative Gate Voltage



Positive Gate Voltage



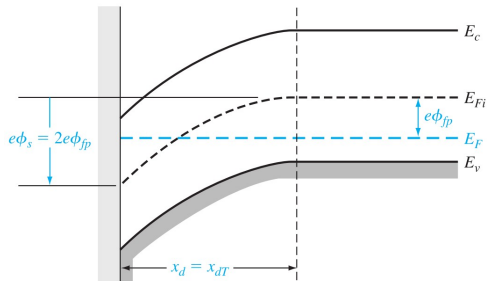
Depletion Layer Thickness



$$\phi_{fp} = V_t \ln \left(\frac{N_a}{n_i} \right)$$
$$x_d = \left(\frac{2\epsilon_s \phi_s}{eN_a} \right)^{1/2}$$

ϕ_s : the surface potential, is the difference (in V) between E_{Fi} measured in the bulk semiconductor and E_{Fi} measured at the surface.

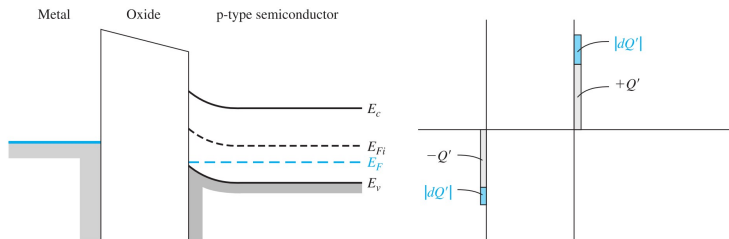
Threshold Inversion Point



$$\phi_s = 2\phi_{fp}$$

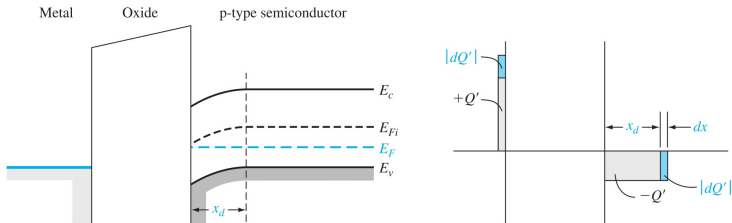
$$x_{dT} = \left(\frac{4\epsilon_s \phi_{fp}}{eN_a} \right)^{1/2}$$

Accumulation



$$C'(\text{acc}) = C_{ox} = \frac{\epsilon_{ox}}{t_{ox}}$$

Depletion

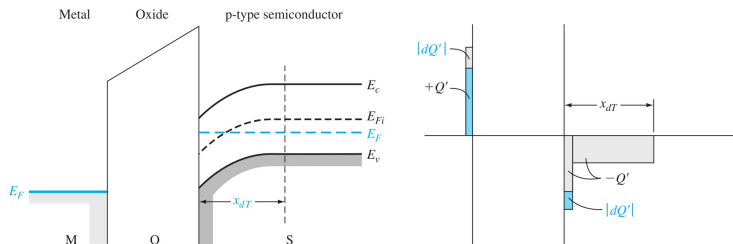


$$C'(\text{depl}) = \frac{C_{ox} C'_{SD}}{C_{ox} + C'_{SD}}$$

$$= \frac{\epsilon_{ox}}{t_{ox} + \left(\frac{\epsilon_{ox}}{\epsilon_s} \right) x_d}$$

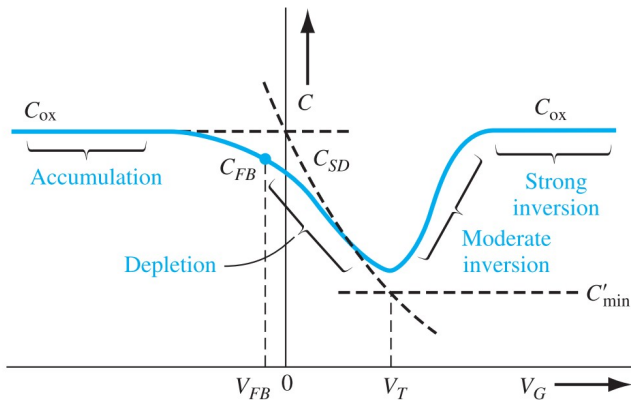
$$C'_{min} = \frac{\epsilon_{ox}}{t_{ox} + \left(\frac{\epsilon_{ox}}{\epsilon_s} \right) x_d T}$$

Inversion



$$C'(\text{inv}) = C_{ox} = \frac{\epsilon_{ox}}{t_{ox}}$$

Ideal Low-Frequency C-V Curve

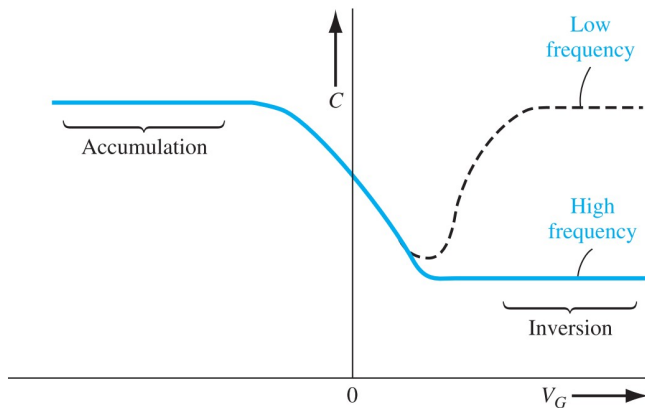


$$C'_{FB} = \frac{\epsilon_{ox}}{t_{ox} + \left(\frac{\epsilon_{ox}}{\epsilon_s}\right) \sqrt{\left(\frac{kT}{e}\right) \left(\frac{\epsilon_s}{eN_a}\right)}}$$

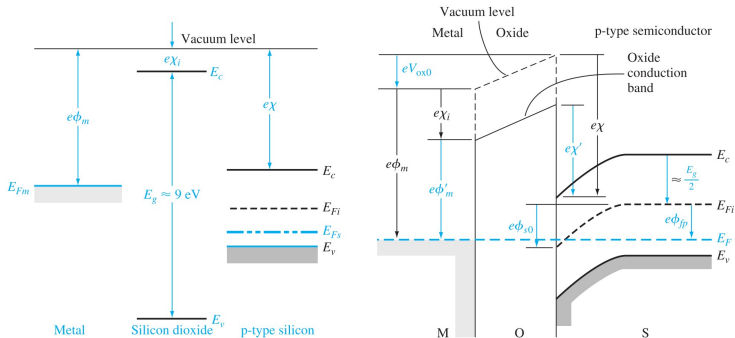
Frequency Effects

Two sources of electrons

1. Diffusion of minority carrier electrons.
2. Thermal generation of electron-hole pairs within the space charge region.



Work Function Difference

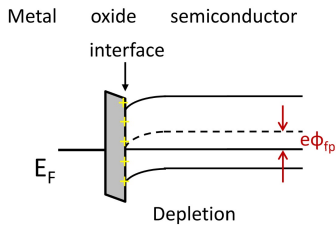
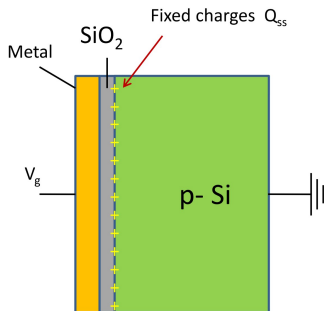


$$\phi_{ms} = \phi'_m - \left(\chi' + \frac{E_g}{2e} + \phi_{fp} \right)$$

$$\phi_{ms} = \phi'_m - \left(\chi' + \frac{E_g}{2e} - \phi_{fn} \right)$$

Not required.

Fixed Charge



Adjustment on V_T

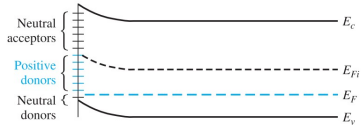
$$|Q'_{SD}(\max)| = eN_a x_{dT} = 2\sqrt{e\epsilon_s N_a \phi_{fp}}$$

$$V_{TN} = \frac{|Q'_{SD}(\max)|}{C_{ox}} + V_{FB} + 2\phi_{fp}$$

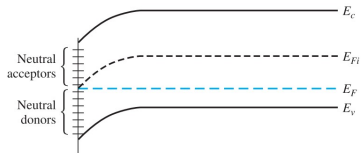
$$V_{TP} = -\frac{|Q'_{SD}(\max)|}{C_{ox}} + V_{FB} - 2\phi_{fn}$$

$$V_{FB} = \phi_{ms} - \frac{Q'_{ss}}{C_{ox}} \cdot \frac{x}{d}$$

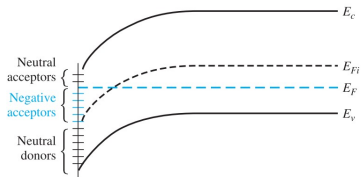
Surface States



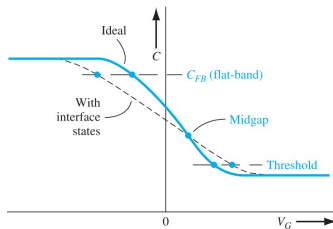
(a)



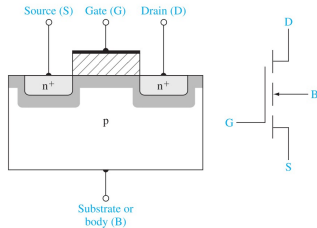
(b)



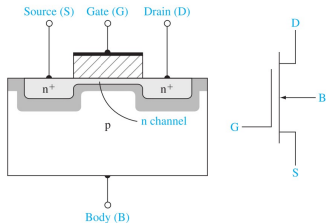
(c)



MOSFET



(a) n-channel enhancement MOSFET

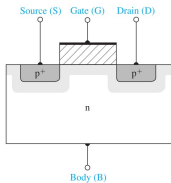


(b) n-channel depletion MOSFET

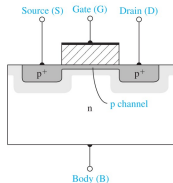
Enhancement mode: the semiconductor substrate is not inverted directly under the oxide with zero gate voltage.

Depletion mode: a p-channel region exists under the oxide with 0V applied to the gate.

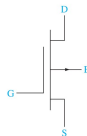
MOSFET



(a) p-channel enhancement MOSFET



(b) p-channel depletion MOSFET



$$V_{GS} - V_T$$

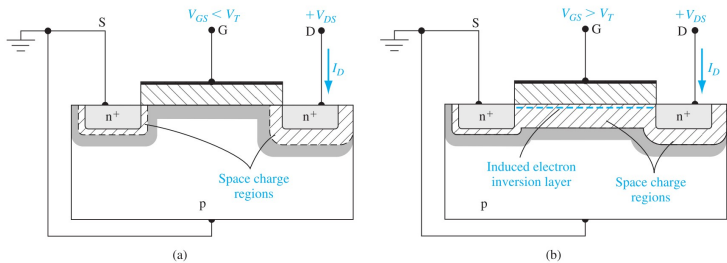


Figure: (a) $V_{GS} < V_T$, (b) $V_{GS} > V_T$

- ▶ $V_{GS} < V_T$: no inversion layer, no current.
- ▶ $V_{GS} > V_T$: inversion layer created, current flow from drain to source.

V_{DS} when $V_{GS} > V_T$

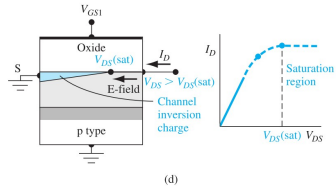
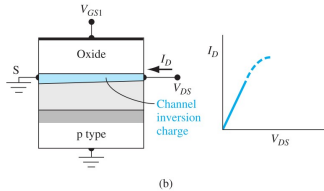
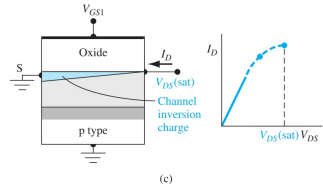
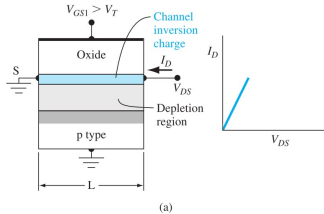
- ▶ V_{DS} low ($V_{DS} < V_{GS} - V_T$): act as a controllable resistor.

$$I_D = \mu_n C_{ox} \frac{W}{L} \left(V_{GS} - V_T - \frac{V_{DS}}{2} \right) V_{DS}$$

- ▶ V_{DS} high ($V_{DS} \geq V_{GS} - V_T$): saturation

$$I_D = \mu_n C_{ox} \frac{W}{2L} (V_{GS} - V_T)^2 \quad (\text{saturation})$$

$$V_{GS} - V_T$$

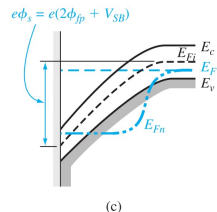
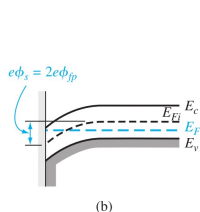
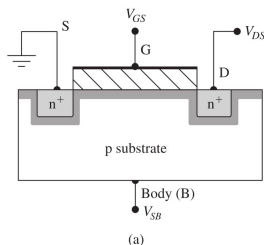


After pinch off: the electrons are injected into the space charge region where they are swept by the E-field to the drain contact.

Transconductance

$$g_m = \frac{\partial I_D}{\partial V_{GS}}$$
$$= \begin{cases} \mu_n C_{ox} \frac{W}{L} V_{DS}, & 0 < V_{DS} < V_{GS} - V_T \\ \mu_n C_{ox} \frac{W}{L} (V_{GS} - V_T), & V_{DS} > V_{GS} - V_T \end{cases}$$

Substrate Bias Effects



$$V_{SB} = 0 : Q'_{SD}(\text{max}) = -\sqrt{2e\epsilon_s N_a (2\phi_{fp})}$$

$$V_{SB} > 0 : Q'_{SD} = -\sqrt{2e\epsilon_s N_a (2\phi_{fp} + V_{SB})}$$

$$\Delta V_T = -\frac{\Delta Q'_{SD}}{C_{ox}} = \frac{\sqrt{2e\epsilon_s N_a}}{C_{ox}} \left[\sqrt{2\phi_{fp} + V_{SB}} - \sqrt{2\phi_{fp}} \right]$$

where $\Delta V_T = V_T(V_{SB} > 0) - V_T(V_{SB} = 0)$ for NMOS.

Substrate Bias Effects

$$\Delta V_T = -\frac{\Delta Q'_{SD}}{C_{ox}} = \frac{\sqrt{2e\epsilon_s N_a}}{C_{ox}} \left[\sqrt{2\phi_{fp} + V_{SB}} - \sqrt{2\phi_{fp}} \right]$$
$$= \gamma \left[\sqrt{2\phi_{fp} + V_{SB}} - \sqrt{2\phi_{fp}} \right], \quad \gamma = \frac{\sqrt{2e\epsilon_s N_a}}{C_{ox}}$$

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I - Subthreshold Conduction (Leakage Current)

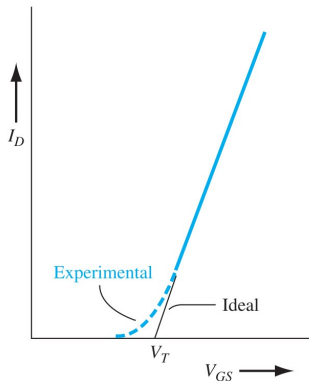
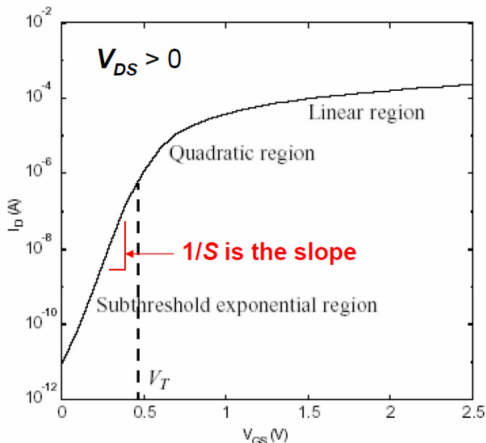


Figure: Comparison of ideal and experimental plots of $\sqrt{I_D}$ versus V_{GS} .

When $V_{GS} < V_T$, $I_D \propto \exp\left(\frac{qV_{GS}}{nkT}\right)$

I - Subthreshold Conduction (Leakage Current)

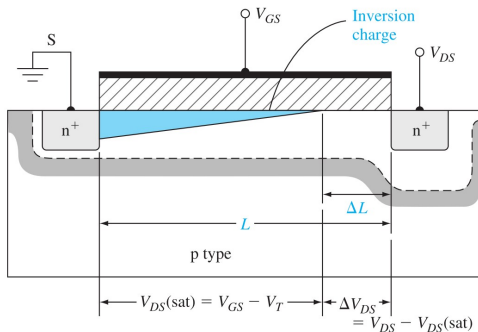
Slope Factor: defined to be the inverse slope of the $\log(I_D)$ vs. V_{GS} characteristic in the subthreshold region.



$$S = n \left(\frac{kT}{q} \ln(10) \right) \text{ (Volts per decade)}$$

$S \geq 60 \text{ mV/dec}$ at room temperature.

II - Channel Length Modulation



$$I'_D = \mu_n C_{ox} \frac{W}{2L} \left[(V_{GS} - V_T)^2 (1 + \lambda V_{DS}) \right]$$

III - Velocity Saturation

$$I_{DSAT} = WC_{ox} \left[V_{GS} - V_T - \frac{V_{DSAT}}{2} \right] v_{sat}$$

where $V_{DSAT} = \frac{L}{\mu_n} v_{sat}$.

IV - Short Channel Effect

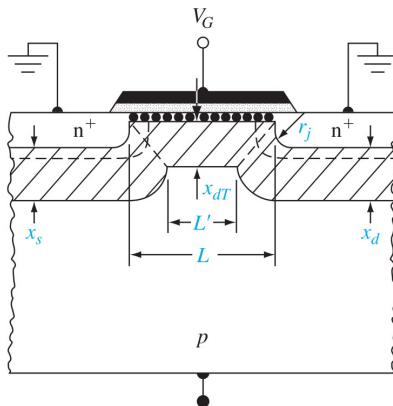
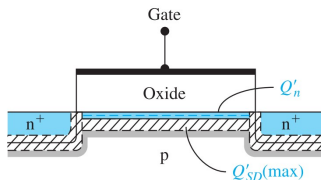


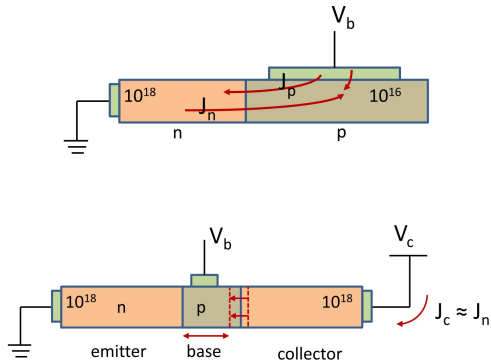
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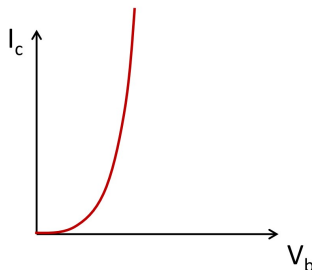
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Bipolar Junction Transistor



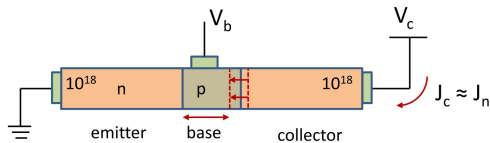
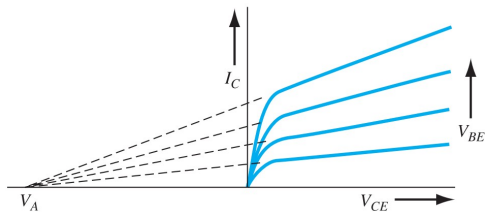
Current Volatage Relationship



$$I_c = \beta I_s \left(e^{\frac{eV_b}{nkT}} - 1 \right)$$

1. Narrower base \rightarrow larger gain
2. $\beta \approx N_D/N_A$, higher emitter-to-base ratio \rightarrow higher gain

Early Effect



Trade off:
Gain and Early effect.

Good luck to your final exam!